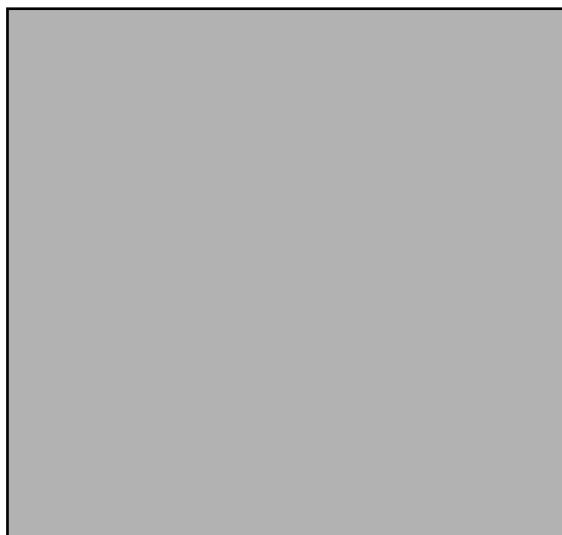
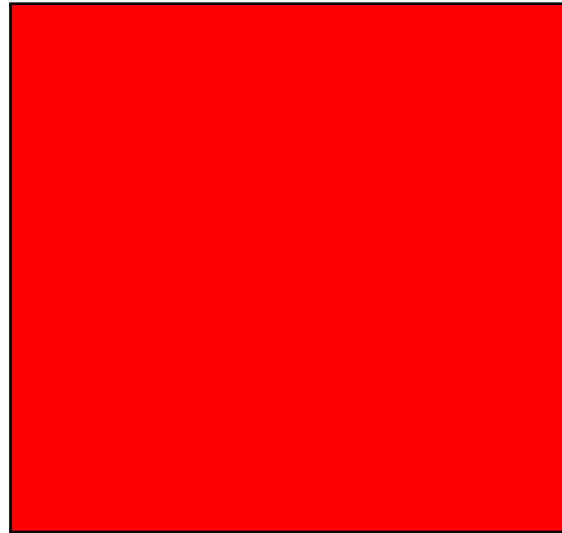


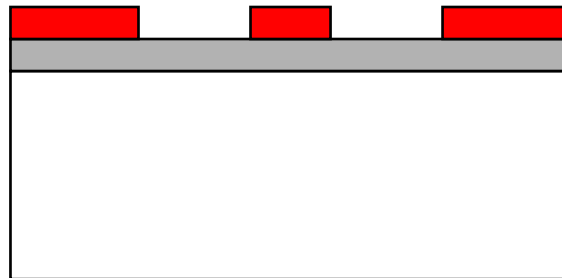
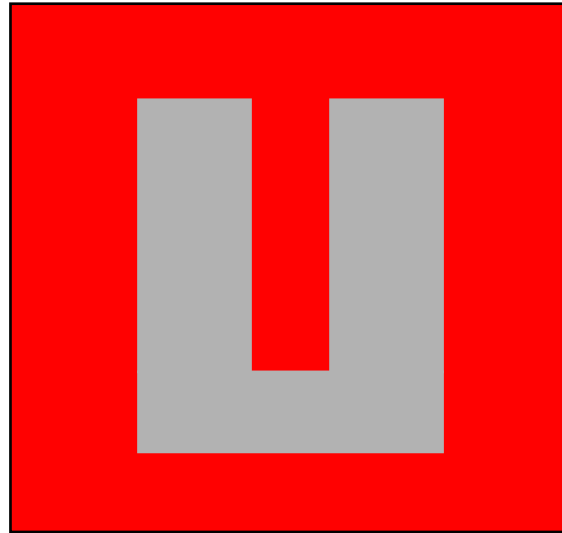
Silicon substrate



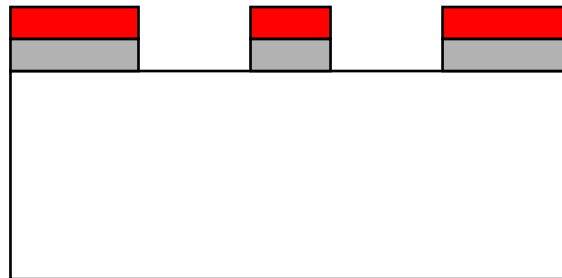
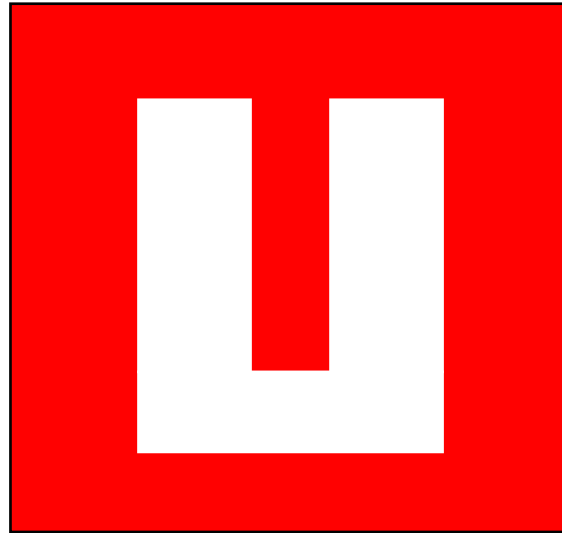
Film deposition



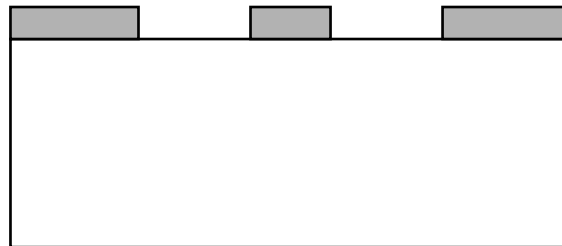
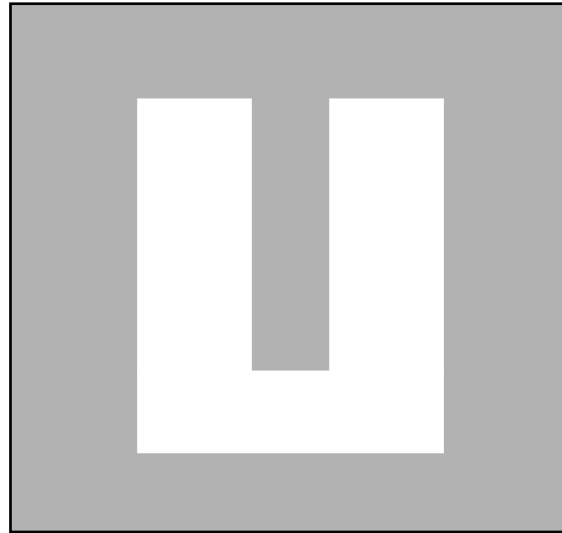
Photolithography - I

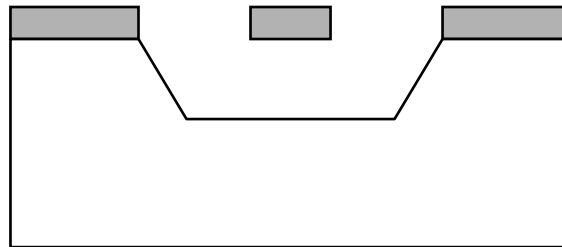
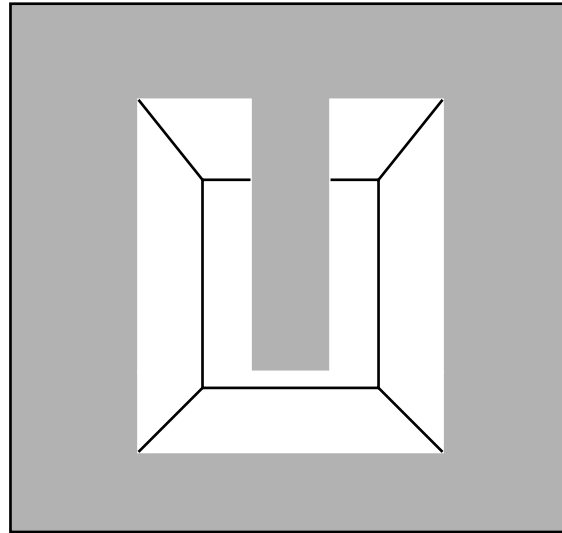


Photolithography - II

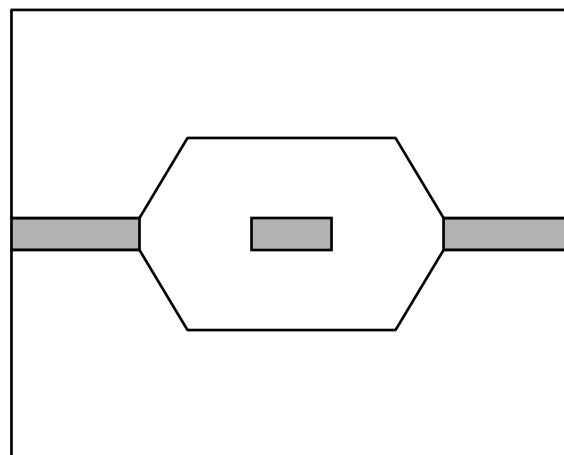


Etching





Etching



Bonding